

**RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2892**

Attorney's Docket No. 5649-1277

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re: Kwang-hee Lee et al.

Examiner: Thanh Y. Tran

Serial No.: 10/801,208

Group Art Unit: 2892

Filed: March 16, 2004

Confirmation No.: 2034

For: METHODS OF MANUFACTURING SEMICONDUCTOR DEVICES HAVING A  
RUTHENIUM LAYER VIA AUTOMATIC LAYER DEPOSITION

Date: November 18, 2008

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE AFTER FINAL**

Sir:

Applicants submit the present *Response After Final* to address the rejections set forth in the Final Office Action mailed October 16, 2008.

It is not believed that an extension of time and/or additional fee(s) -- including fees for net addition of claims -- are required, beyond those that may otherwise be provided for in documents accompanying this paper. In the event, however, that an extension of time is necessary to allow consideration of this paper, such an extension is hereby petitioned under 37 C.F.R. §1.136(a). Any additional fees believed to be due in connection with this paper may be charged to our Deposit Account No. 50-0220.